PATENT

FECHNOLOGY CENTER 2800



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Ubaldo Mastromatteo

Application No.

10/037,485

Filed

For

PROCESS FOR MANUFACTURING INTEGRATED DEVI December 19, 2001 HAVING CONNECTIONS ON A SEPARATE WAFER, AND

INTEGRATED DEVICE THUS OBTAINED

Examiner

Hung K. Vu

Art Unit

2811

Docket No.

854063.665

Date

March 4, 2003

Commissioner for Patents Washington, DC 20231

AMENDMENT

In response to the Office Action dated December 4, 2002, please amend the Commissioner for Patents: application as follows:

In the Claims:

For the convenience of the Examiner, all pending claims have been included.

Please amend claims 1, 4, 5, 11, and 30 to read as follows:

comprising:

device, integrated for manufacturing an (Amended) A process

forming integrated structures including semiconductor regions and isolation 1.

regions in a first wafer of semiconductor material;

03/10/2003 BABRAHA1 00000033 10037485

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